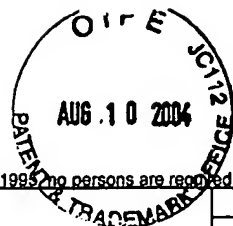


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<p>Substitute for Form 1449A/PTO</p> <p>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</p> <p>(use as many sheets as necessary)</p>				Complete If Known	
				Application Number	10/811,112
				Filing Date	March 26, 2004
				First Named Inventor	Dipl.-Ing. Daniel Supper
				Group Art Unit	
				Examiner Name	2811
Sheet	1	of	1	Attorney Docket No.	MAIKP128US

U.S. PATENT DOCUMENTS						
Exam. Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Doc.	Date of Pub. of Cited Doc. (mm-dd-yyyy)	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS					
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AKS	CA	"Transverse Mode Selection in Large-Area Oxide-Confining Vertical-Cavity Surface-Emitting Lasers Using a Shallow Surface Relief", H. MARTINSSON, J.A. VUKUSIC, M. GRABHERR, M. MICHALZIK, R. JÄGER, K.J. EBELING, and A. LARSSON, IEEE Photonics Technology Letter, Vol. 11, No. 12, December 1999, pgs. 1536-1538.			
AKS	CB	"Increased-area oxidized single-fundamental mode VCSEL with self-aligned shallow etched surface relief", H.J. UNOLD, M. GRABHERR, F. EBERHARD, F. MEDERER, R. JÄGER, M. RIEDL, and K.J. EBELING, Electronics Letters, 5 th August 1999, Vol. 35, No. 16, pgs. 1340-1341.			
	CC				
	CD				
	CE				
	CF				
	CG				
	CH				

Examiner Signature	<i>Ashe Kumar Sarker</i>	Date Considered	11/17/05
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